



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Yasuaki TANAKA, et al.

Application Division

Serial Number: 10/091,325

Confirmation No: 7967

Filed: March 6, 2002

For: METHOD AND DEVICE FOR EXPOSURE CONTROL, METHOD AND DEVICE

FOR EXPOSURE, AND METHOD OF MANUFACTURE OF SAME

REQUEST FOR CORRECTED FILING RECEIPT

Mail Stop: Missing Parts Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Customer No.:38834 Atty. Docket No. 991186A

October 12, 2004

Sir:

Please supply the undersigned attorney with a corrected filing receipt for the above-identified application. The undersigned also respectfully requests that the Patent and Trademark Office records be amended to reflect the correction.

In reviewing the Official Filing Receipt, we noted an error in the Power of Attorney and an omission in the First Inventor. The Power of Attorney should read -- The patent practitioners associated with Customer Number 38834--and the First Inventor should read -- Yasuaki Tanaka Tokyo, JAPAN--. A copy of the Patent Application Information Retrieval and the Declaration are enclosed which indicates the correct information. We are enclosing a copy of the filing receipt with the corrections highlighted.

In the event that any fees are required in connection with this paper, please charge our Deposit Account No. <u>50-2866</u>.

Respectfully submitted,

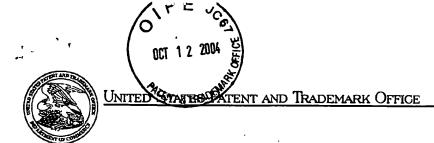
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Steffien G. Adrian Attorney for Applicants Reg. No. 32,878

Tel: (202) 822-1100 Fax: (202) 822-1111

SGA/rf

Enclosures: Official Filing Receipt; Patent Application Information Retrieval; Declaration



UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address COMMISSIONER FOR PATENTS P.O. Dox 1450 Alexandris, Viginia 22313-1450 www.usptugov

FILING OR 371 APPL NO. ART UNIT **FIL FEE RE** TTY DOCKET NO DRAWINGS **TOT CLMS** IND CLMS (c) DATE 03/06/2002 10/091,325 2851 4590 33 61 29 **CONFIRMATION NO. 7967** 0CT 38834 G RECEIPT WESTERMAN, HATTORI, DANIELS & ADRIAN, LILP 1250 CONNECTICUT AVENUE, NW WESTERMAN, HATTORI 'OC000000013984179* DANIELS & ADRIAN, LLP SUITE 700 WASHINGTON, DC 20036

Date Mailed: 10/04/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s) Yasuaki Tanaka, Tokyo, JAPAN Please Michio Noboru, Tokyo, JAPAN;

Assignment For Published Patent Application

Nikon Corporation, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 23850.

Domestic Priority data as claimed by applicant

This application is a CON of 09/421,331 10/18/1999 ABN which is a CON of PCT/JP98/01777 04/17/1998

Foreign Applications

JAPAN 116255-1997 04/18/1997 JAPAN 109748/1997 04/25/1997 JAPAN 124527/1997 05/14/1997

If Required, Foreign Filing License Granted: 04/11/2002

The number of your priority application, to be used for filing abroad under the Paris Convention is, US10/091,325

Projected Publication Date: To Be Determined - pending completion of Corrected Papers

Non-Publication Request: No

Early Publication Request: No

Title

Method and device for exposure control, method and device for exposure, and method of manufacture of device

Preliminary Class

355

LICENSE FOR FOREIGN FILING UNDER Title 35, United States Code, Section 184 Title 37, Code of Federal Regulations, 5.11 & 5.15

GRANTED

The applicant has been granted a license under 35 U.S.C. 184, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" followed by a date appears on this form. Such licenses are issued in all applications where the conditions for issuance of a license have been met, regardless of whether or not a license may be required as set forth in 37 CFR 5.15. The scope and limitations of this license are set forth in 37 CFR 5.15(a) unless an earlier license has been issued under 37 CFR 5.15(b). The license is subject to revocation upon written notification. The date indicated is the effective date of the license, unless an earlier license of similar scope has been granted under 37 CFR 5.13 or 5.14.

This license is to be retained by the licensee and may be used at any time on or after the effective date thereof unless it is revoked. This license is automatically transferred to any related applications(s) filed under 37 CFR 1.53(d). This license is not retroactive.

The grant of a license does not in any way lessen the responsibility of a licensee for the security of the subject matter as imposed by any Government contract or the provisions of existing laws relating to espionage and the national security or the export of technical data. Licensees should apprise themselves of current regulations especially with respect to certain countries, of other agencies, particularly the Office of Defense Trade Controls, Department of State (with respect to Arms, Munitions and Implements of War (22 CFR 121-128)); the Office of Export Administration, Department of Commerce (15 CFR 370.10 (j)); the Office of Foreign Assets Control, Department of Treasury (31 CFR Parts 500+) and the Department of Energy.

NOT GRANTED

No license under 35 U.S.C. 184 has been granted at this time, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" DOES NOT appear on this form. Applicant may still petition for a license under 37 CFR 5.12, if a license is desired before the expiration of 6 months from the filing date of the application. If 6 months has lapsed from the filing date of this application and the licensee has not received any indication of a secrecy order under 35 U.S.C. 181, the licensee may foreign file the application pursuant to 37 CFR 5.15(b).



United States Patent and Trademark Office

Home | Site Index | Search | Guides | Contacts | eBusiness | eBiz alerts | News | Help

PATENT APPLICATION INFORMATION RETRIEVAL





Other Links



⊟ Printer Friendly Version		Search results as of: 10-7-2004::14:30		
Sea	rch results fo	r application number:10/091,325		
Application Number:	10/091,325	Customer Number:	38834	
Filing or 371(c) Date:	03-06-2002	Status:	Application Returned back to Preexam	
Application Type:	Utility	Status Date:	10-01-2004	
Examiner Name:	•	Location:	OIPE - REISSUE/ABANDONMI PROCESSING, CP2-5B16	
Group Art Unit:	2851	Location Date:	09-27-2004	
Confirmation Number:	7967	Earliest Publication No:	1_	
Attorney Docket Number:	991186A	Earliest Publication Date:	-	
Class/ Sub- Class:	-/-	Patent Number:	-	
	Michio Noboru, Tokyo, (JP)	Issue Date of Patent:	I -	
	Method and device for exposure control, method and device for exposure, and method of manufacture of device			

Select Search Option

Continuity Data Foreign Priority

Publication Review

Search

	File History		
Date	Contents Description		
10-04-2004	Corrected Paper		
03-06-2002	Drawing Preliminary Amendment		
10-01-2004	Pre-Exam Office Action Withdrawn		
10-01-2004	Application Return TO OIPE		
10-01-2004	Application Dispatched from OIPE		
10-01-2004	Application Is Now Complete		
09-03-2004	Additional Application Filing Fees		
09-03-2004	Applicant has submitted new drawings to correct Corrected Papers		
09-27-2004	Withdraw Publication/Pre-Exam Abandon		
09-14-2004	Correspondence Address Change		
09-03-2004	Workflow incoming petition IFW		
09-03-2004	Workflow incoming petition IFW		

06-13-2002	Abandonment During Preexam Processing	
03-28-2002	IFW Scan & PACR Auto Security Review	
03-19-2002	IFW Scan & PACR Auto Security Review	
03-06-2002	Initial Exam Team nn	

|.HOME|INDEX|SEARCH|eBUSINESS|CONTACT US|PRIVACY STATEMENT